

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Olivier RAYSSAC et al.

Confirmation No.: 1187

Application No: 10/775,917

Group Art Unit: 2822

Filing Date: February 9, 2004

Examiner: M. Trinh

For: METHOD OF OBTAINING A SELF-
SUPPORTED THIN SEMICONDUCTOR LAYER
FOR ELECTRONIC CIRCUITS

Atty. Docket No.: 4717-13100

AMENDMENT

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

In response to the final Office Action dated August 19, 2008, please enter the following amendments and comments into the file of this application.

Amendments to the claims are reflected in the complete listing of all claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

No additional fee is believed to be due for this submission. Please charge any required fees to Winston & Strawn LLP Deposit Account No. 50-1814.

DO NOT ENTER: /MT/